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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Joon Hyeon LEE

SERIAL NO.: 10/731,482

EXAMINER: Gurley, Lynne Ann

FILED: December 10, 2003

GROUP ART UNIT: 2812

FOR: METHOD OF FORMING METAL LINE LAYER IN SEMICONDUCTOR DEVICE

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AMENDMENT

Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 9, 2004

Sir:

Responsive to the outstanding Office Action dated August 10, 2004, entry of the following amendments and remarks is respectfully requested.